| Ref<br># | Hits | Search Query  | DBs   | Default<br>Operator | Plurals | Time Stamp       |
|----------|------|---|---|---------------------|---------|------------------|
| L1       | 242  | bruel.in.   | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR                  | OFF     | 2005/04/16 11:01 |
| L2       | 85   | bruel.in. and implantation  | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR .                | OFF     | 2005/04/16 11:01 |
| L3       | 26   | 2 and etch\$3   | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR                  | OFF     | 2005/04/16 11:01 |
| L4       | 267  | (deposit\$3 near3 (Si silicon)) and ((smooth\$3 flatten\$4) near3 (Si silicon) near12 etch\$3)  | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR                  | OFF     | 2005/04/16 11:43 |
| L5       | 32   | 4 and (silicon adj insulator)   | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR                  | OFF     | 2005/04/16 11:15 |
| L6       | 18   | (deposit\$3 near3 (Si silicon)) and ((smooth\$3 flatten\$4) near3 (Si silicon) near12 (RIE ((irradiat\$3 beam) near3 etch\$3)))   | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR                  | OFF     | 2005/04/16 11:44 |
| L8       | . 2  | "5650043".pn.   | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR                  | OFF     | 2005/04/16 12:30 |
| S1       | 5    | ((ammonium adj2 hydroxide) or<br>"NH.sub.4OH" or "NH.sub.4 OH")<br>near12 ((ammonium adj2 fluoride)<br>or "NH.sub.4F" "NH.sub.4 F")<br>near12 etch\$3 near4<br>(semiconductor silicon Si) | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR                  | OFF     | 2005/04/16 11:01 |
| S2       | 1721 | (deposit\$3 near3 (Si silicon)) and ((smooth\$3 flatten\$4) near3 (Si silicon))   | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR                  | OFF     | 2005/04/15 22:02 |

| S3 | 267 | (deposit\$3 near3 (Si silicon)) and<br>((smooth\$3 flatten\$4) near3 (Si<br>silicon) near12 etch\$3) | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR | OFF | 2005/04/16 11:14 |
|----|-----|--|---|----|-----|------------------|
| S4 | 101 | S3 and ((wet liquid) near3 etch\$3)  | US-PGPUB;<br>USPAT;<br>EPO; JPO;<br>DERWENT;<br>IBM_TDB | OR | OFF | 2005/04/15 22:03 |